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| INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) | | APR 11 2005 | | Applicant: Munir H. Nayfeh | |
| | | Filing Date: February 2, 2000 | | Group: 2811 | |

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| Examiner | CRANE | Date Considered | 6/2005 |
| *Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | |